METHOD OF FORMING TRANSPARENT CONDUCTIVE LAYER ON SUBSTRATE

ABSTRACT OF THE DISCLOSURE

A method of forming a transparent conductive layer on a substrate has the steps of: forming a transparent conductive layer on a flat surface of a temporary substrate, wherein the transparent conductive layer has a first side attached onto the flat surface directly and a second side opposite to the first side; patterning the transparent conductive layer; providing an insulation layer to cover the second side of the transparent conductive layer; providing a substrate on the insulation layer, and removing the temporary substrate to expose the first side of the transparent conductive layer.